

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Takumi MIKAWA et al.)
Japanese Application No. 11-353104) Attn: Applications
Japanese Priority Date: December 13, 1999) Branch
For: SEMICONDUCTOR DEVICE AND)
METHOD FOR FABRICATING)
THE SAME)

10862 U.S. PRO
09/734176
12/12/00

INFORMATION DISCLOSURE STATEMENT

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


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